

**Search Notes**

Application No.

10/693,236

Examiner

Kathryn S. O'Malley

Applicant(s)

YAMAGUCHI ET AL.

Art Unit

3749

**SEARCHED**

Class	Subclass	Date	Examiner
34	463, 487, 506, 498, 467, 459	9/30/2004	KSO
34	444		
134	902		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
34	as above	9/30/2004	KSO

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST Search (see notes)	9/30/2004	KSO
Inventor Search		
Keyword Search: dry\$3, wafer, substrate, guide, vane, direct, diameter, ipa, isopropyl, nitrogen, inert		
Considered Parent Application 10/235069, now US Patent 6,779,534		